

## WEST Search History

DATE: Wednesday, June 13, 2007

Hide?	Set Name	Query	Hit Count
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L7	5934566.pn.	1
		<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L6	(clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3) with (size or diameter or radius or dimension))	19
		<i>DB=EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L5	(semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3)) same (size or diameter or radius or dimension)	0
		<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L4	(semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3)) same (size or diameter or radius or dimension)	11
		<i>DB=EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L3	(semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3))	11
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L2	L1	28
		<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L1	(semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3))	44

END OF SEARCH HISTORY